

1746 0400 06-04-01

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

HIDEO KITAGAWA ET AL.

Application No.: 09/832,978

Filed: April 12, 2001

For: METHOD OF ETCHING ORGANIC FILM AND METHOD OF PRODUCING ELEMENT

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Lexaminer: Not Yet Assigned

Group Art Unit: NYA

June 4, 2001

Commissioner for Patents Washington, D.C. 20231

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are also enclosed.

The concise explanation of relevance for the non-English documents may be found, inter alia, in the specification where they are cited and in the English Abstracts attached thereto. With regard to JP 2786198, the English Abstract is that of Japanese Patent Application Laid-Open No. 1-280311 from which JP 2786918 issued. Also, the concise explanation of relevance for JP 11-40397 may be found in the corresponding European Patent Application No.

80164A1, which is enclosed for the Examiner's convenience. The Examiner's attention is also directed to the AECENEURIA TO TO following U.S. Applications:

APPLICATION NO.	FILING DATE	GROUP ART UNIT
09/082,006	05/20/98	1765
09/580,408	05/30/00	1765

A copy of each cited Application is enclosed.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicants' undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

Registration No.

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